							
AMENDI Applicant(s): Jifa		TTAL LETTER (La	rge Entity)	111	Docket No. 90065.99R272(17732.6323)		
Application No. 09/654,845	Filing Date September 1, 2000	Examiner Ori Nadav	Customer N 34799	No. Group Art Ur 2811	Confirmation No. 6844		
Invention: POWER SEMICONDUCTOR DEVICE WITH HIGH AVALANCHE CAPABILITY AND PROCESS FOR FORMING SAME							
		COMMISSIONER FO	R PATENTS:				
Transmitted herew	rith is an amendment in	n the above-identified a	pplication.				
The fee has been o	calculated and is trans	smitted as shown below.					
		CLAIMS AS AM	ENDED				
	CLAIMS REMAINING	HIGHEST#	NUMBER EXTRA	RATE	ADDITIONAL		
	AFTER AMENDMENT	PREV. PAID FOR	CLAIMS PRESENT	KAIL	FEE		
TOTAL CLAIMS	15 -	34 =	0	x \$18.00	\$0.00		
INDEP. CLAIMS	1 -	3 =	0	x \$88.00	\$0.00		
Multiple Dependen	t Claims (check if appl	licable)			\$0.00		
		TOTAL ADDITIONAL F	FEE FOR THIS AME	ENDMENT	\$0.00		
No additional fee is required for amendment. Please charge Deposit Account No.							
Reg. No. 45,044 Law Office of Thomas R. FitzGerald 16 E. Main Street, Suite 210 Rochester, NY 14614-1808 Telephone (585) 454-2250 Fax (585) 454-6364 CC:			I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on December 6, 2004 (Date) Mancguk Signature of Person Mailing Correspondence				

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8) Applicant(s): Jifa Hao, et al.			Docket No. 90065.99R272/17732.6323				
Application No. 09/654,845	Filing Date September 1, 2000	Examiner Ori Nadav	Customer No. 34799	Group Art Unit 2811			
Invention: POWER S. FOR FORMING SAME		VICE WITH HIGH AVALAN CHE CA	PABILITY AND	PROCESS			
I hereby certify that t	his <u>Amendment (tota</u>	l 12 pages) (Identify type of correspondence)					
is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope							
	December 6, 2004	O. Box 1450, Alexandria, VA 22313-14 —.	450" [37 CFR 1.8	3(a)] on			
	(Date)						
		Kathleen A. (Typed or Printed Name of Person		lence)			
	Kathlen a. Manceuk						
		(Signature of Person Mai	ing Correspondence)				
Note: Each paper must have its own certificate of mailing.							
				1			

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

REPLY UNDER 37 CFR 1.116 - EXPEDITED PROCEDURE - EXAMINING GROUP 2811

Applicant:	Jifa Hao, et al.)	
Serial No.:	09/654,845	Examiner: Ori Nadav	
Filed:	September 01, 2000		
Title:	POWER SEMICONDUCTOR DEVICE WITH HIGH AVALANCHE CAPABILITY AND PROCESS FOR FORMING SAME) Art Unit: 2811))))))	

RESPONSE UNDER 37 CFR 1.116

MS: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed 06 October 2004, Applicants hereby submit the following Amendment and Remarks.